

PATENT APPLICATION

\$510.00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Eveniner	A Mathausa		
Shuichi YABU				;	Examiner: A. Mathews Group Art Unit: 2851			
Application No.: 09/811,447				:				
Filed: March 20, 2001					Confirmation No.: 9561			
For: EXPOSURE APPARATUS, GAS REPLACING METHOD, AND METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE					June 2, 2004			
Mail Stop Ar Commissione P.O. Box 145 Alexandria, V	r for Patents					·		
Sir:			•					
	erewith is an Amadditional fee is re		the above-identif	ied a	pplication.			
·	een calculated as	-	ow.					
	John Guidalated as t		CLAIMS AS AME	NDEI	D			
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR		PRESENT EXTRA .	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	87	MINUS	68	=	19	x \$9 \$18	\$342.00	
INDEP. CLAIMS	22	MINUS	20	=	2	x \$42 \$84	\$168.00	
Fee for Multipl	e Dependent claims S	\$140/\$280						
TOTAL ADDITIONAL FEE								

FOR THIS AMENDMENT

	°Verified Statement claiming small entity status is enclosed, if not filed previously.
X	A check in the amount of \$510.00 is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,

Attorney for Applicant

Jack S. Curbert

Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
SEW/eab

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	:	Examiner: A. Mathews
Shuichi YABU)	
	:	Group Art Unit: 2851
Application No.: 09/811,447)	
	:	Confirmation No.: 9561
Filed: March 20, 2001)	
	:	
For: EXPOSURE APPARATUS, GAS)	
REPLACING METHOD, AND METHOD	:	June 2, 2004
OF MANUFACTURING A)	
SEMICONDUCTOR DEVICE	:	

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

<u>AMENDMENT</u>

Sir:

In response to the Official Action dated March 2, 2004, please amend the aboveidentified application as follows:



06/04/2004 MMEKONEN 00000058 061205 09811447

01 FC:1201 172.00 DP 02 FC:1202 4.00 DA 338.00 OP